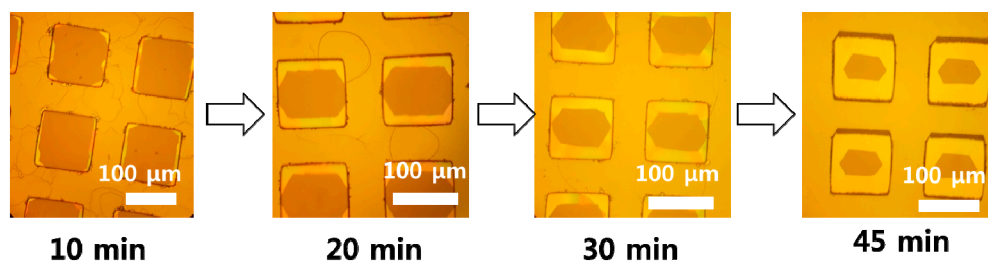
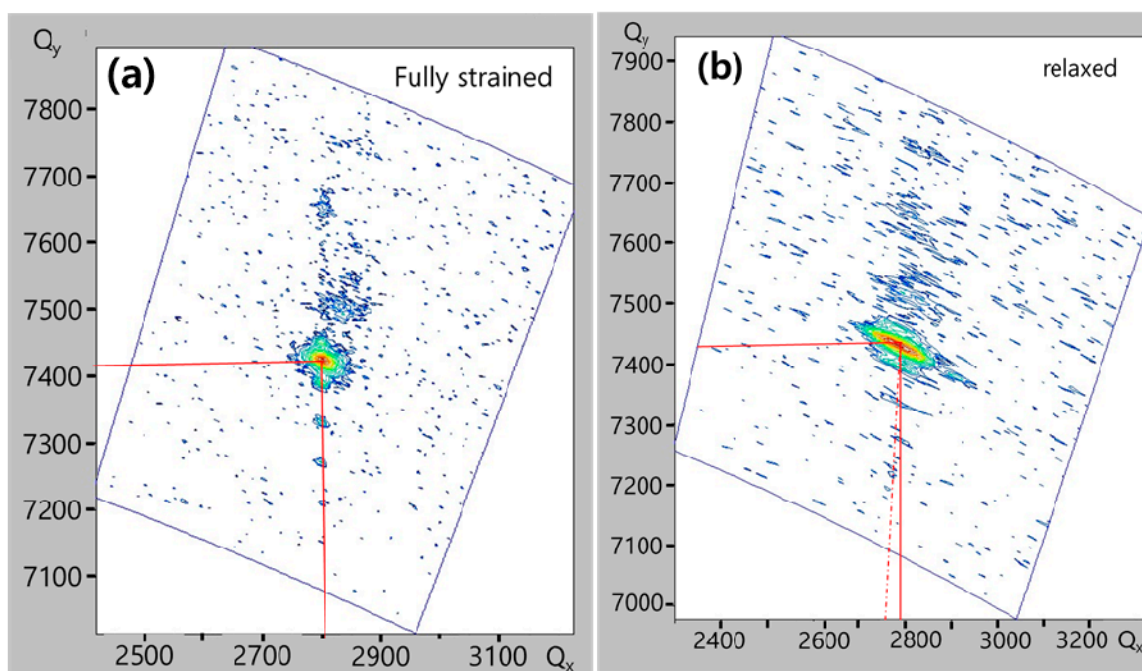


# Supplementary Material: Mass Transfer of Microscale Light-Emitting Diodes to Unusual Substrates by Spontaneously Formed Vertical Tethers During Chemical Lift-Off

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**Figure S1.** Spontaneous formation of vertical tethers.



**Figure S2.** X-ray reciprocal space mapping (RSM) of X-ray diffraction intensity around the (105) reflector for micro LED (a) before and (b) after transfer to Si substrate.